

TITLE: NITRIDE SELECTIVE AND FIELD OXIDE SELECTIVE SEMICONDUCTOR ETCHING  
INVENTORS NAME: Kei-Yu Ko  
DOCKET NO.: 303.696US1

1/7

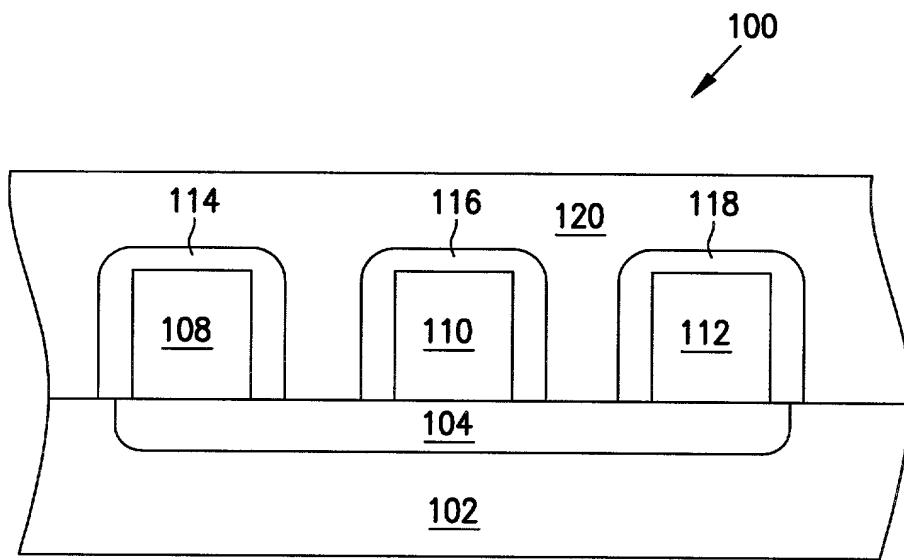


FIG. 1

2/7

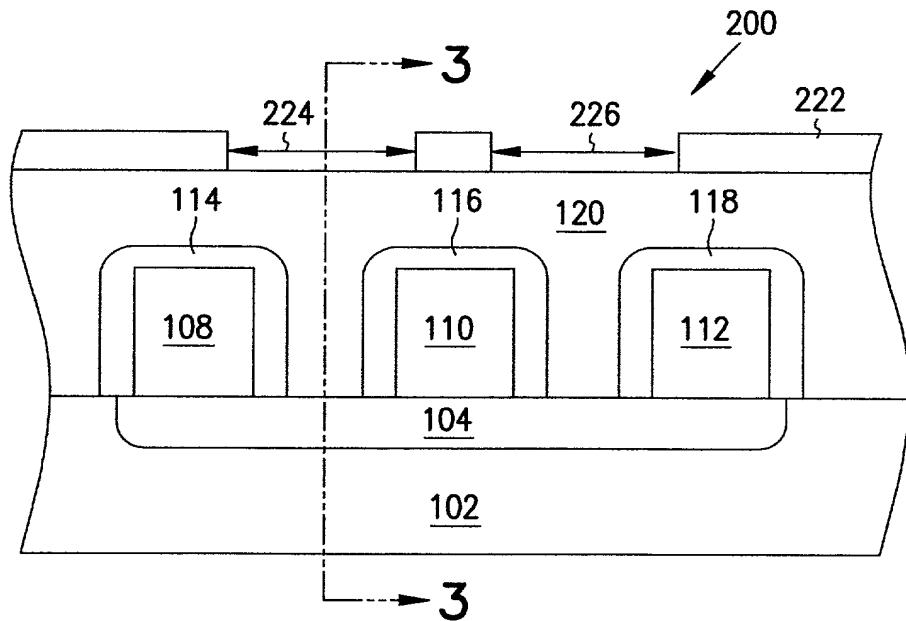


FIG. 2

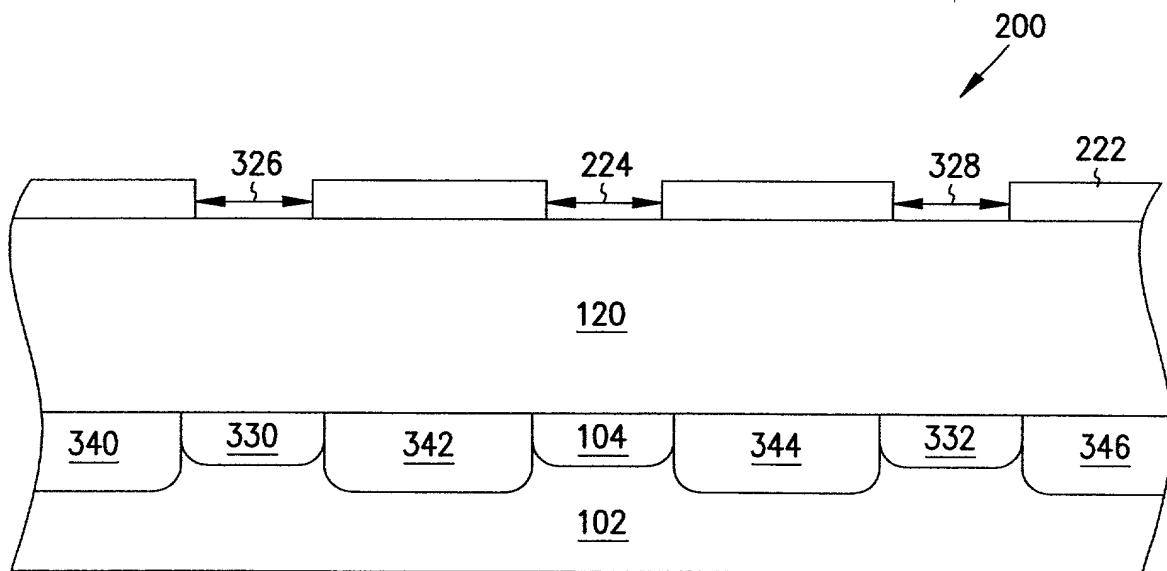


FIG. 3

3/7

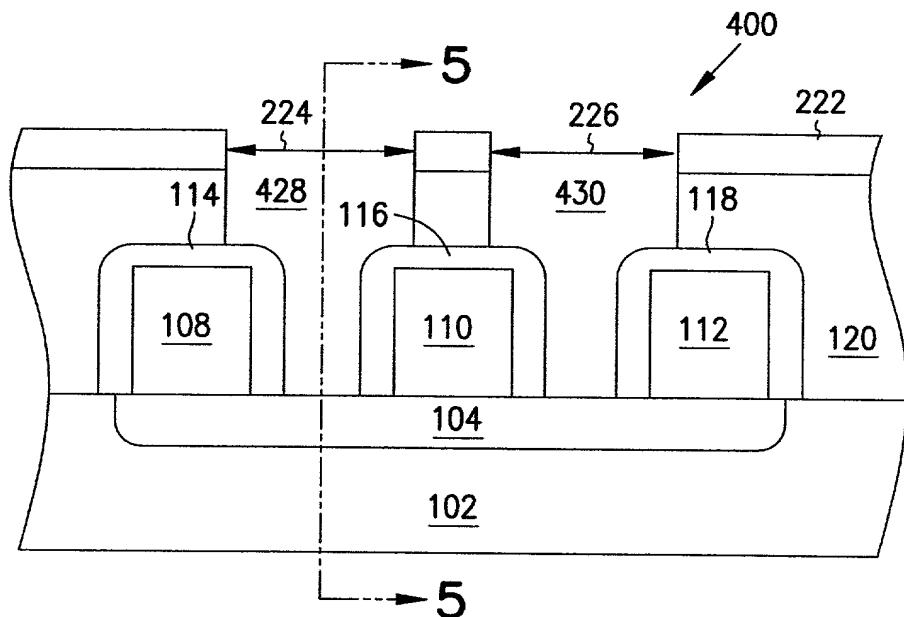


FIG. 4

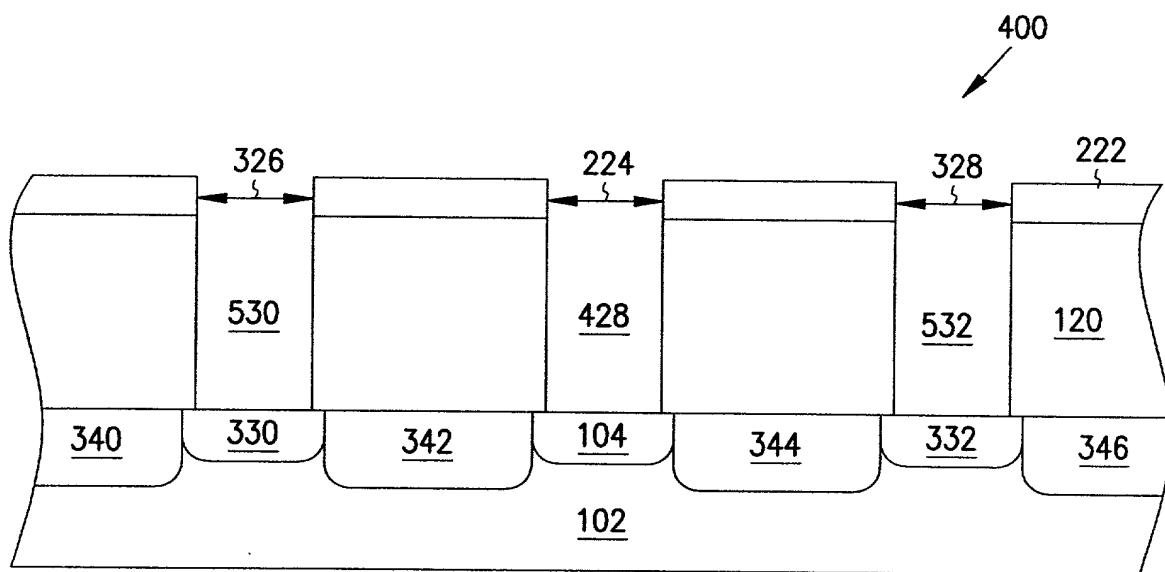


FIG. 5

4/7

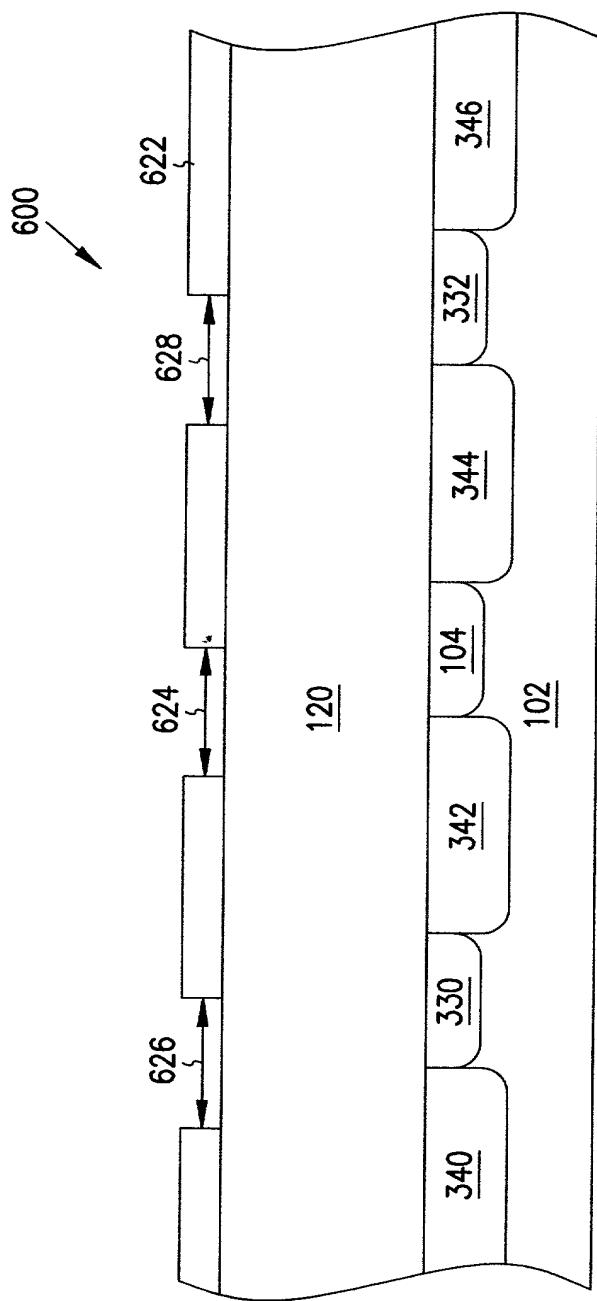


FIG. 6

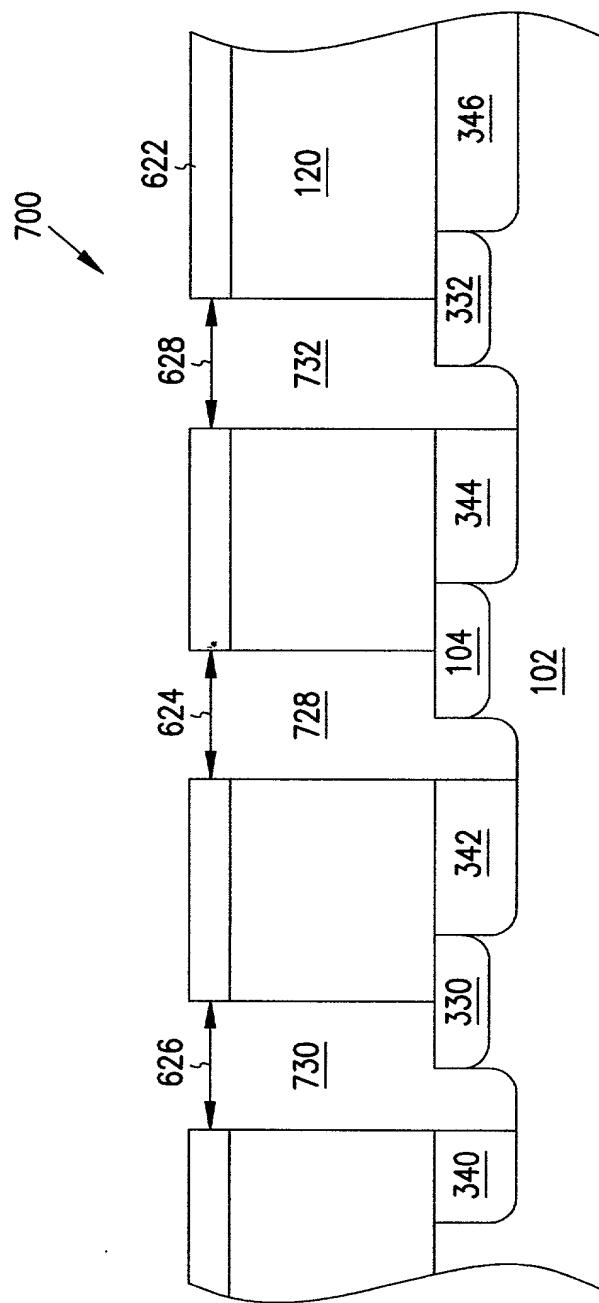


FIG. 7

6/7

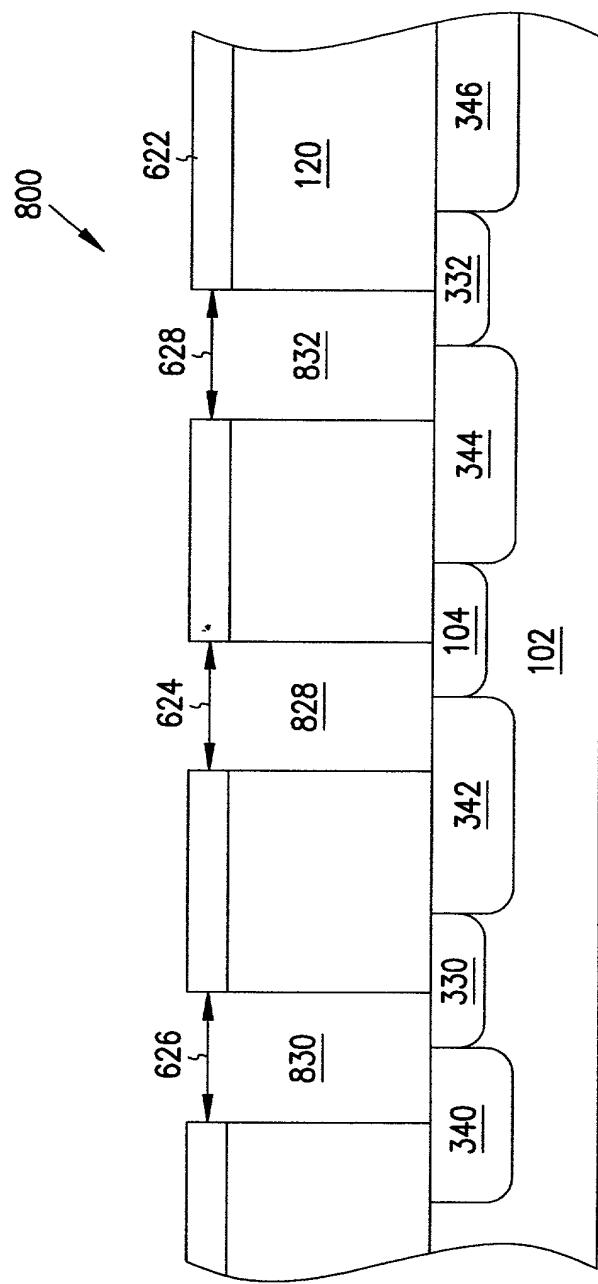


FIG. 8

7/7

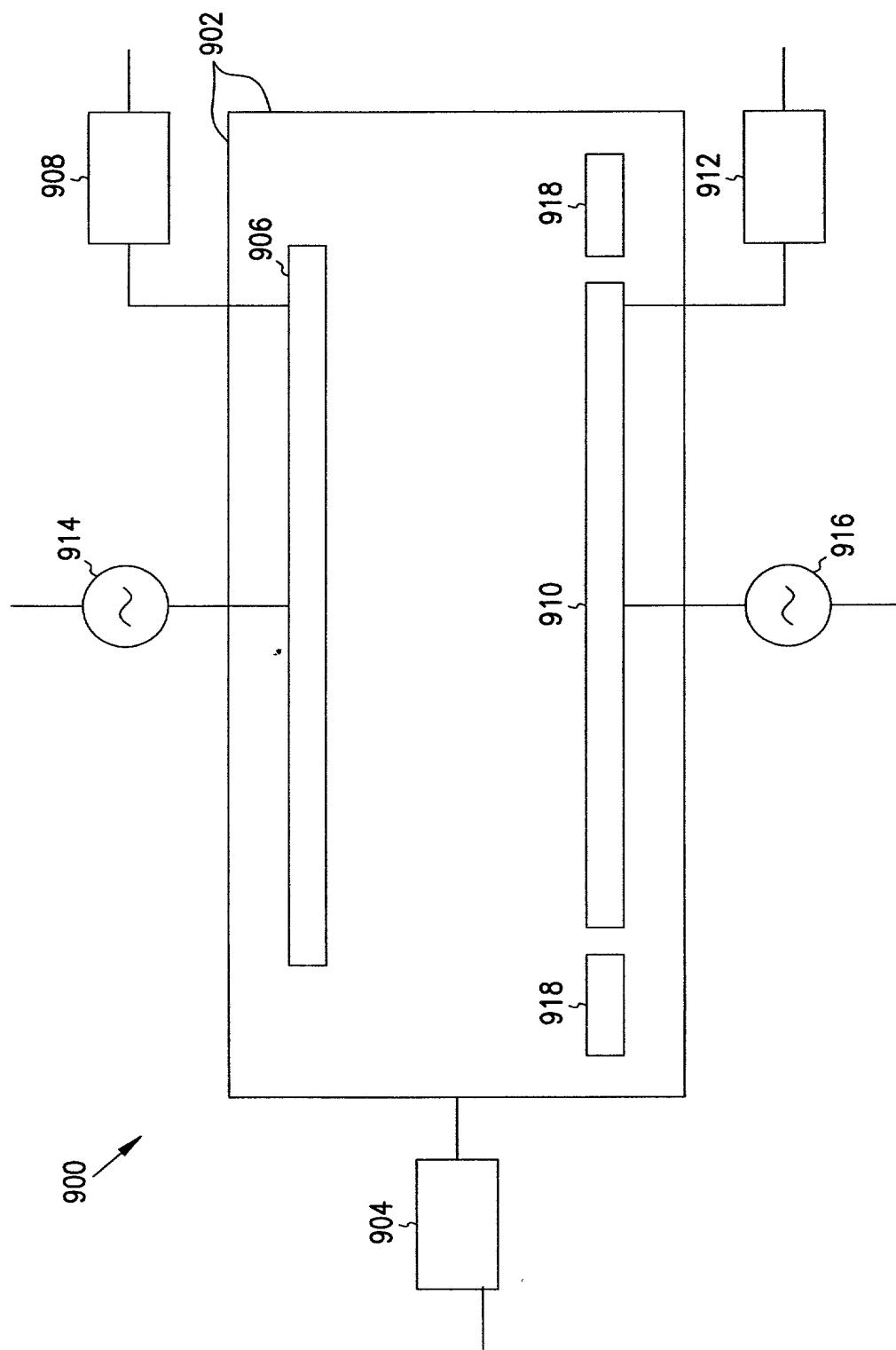


FIG. 9